

L Number	Hits	Search Text	DB	Time stamp
1	46161	(ion dispersive) near3 source	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/01/03 13:11
2	41887	(conductive transmissi\$2) adj2 surface	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/01/03 13:11
3	2321	((conductive transmissi\$2) adj2 surface) with (hole aperture)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/01/03 13:14
4	16561	target adj2 surface	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/01/03 13:14
5	5	((ion dispersive) near3 source) and (((conductive transmissi\$2) adj2 surface) with (hole aperture)) and (target adj2 surface)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/01/03 13:17
6	59	((ion dispersive) near3 source) and (((conductive transmissi\$2) adj2 surface) with (hole aperture))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/01/03 13:18
7	19989	electrostatic adj3 (field potential)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/01/03 13:18
8	1238	((ion dispersive) near3 source) and (electrostatic adj3 (field potential))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/01/03 13:18
10	6	((((ion dispersive) near3 source) and (electrostatic adj3 (field potential))) and ((conductive transmissi\$2) adj2 surface)) and (((conductive transmissi\$2) adj2 surface) with (hole aperture))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/01/03 13:19
9	113	((((ion dispersive) near3 source) and (electrostatic adj3 (field potential))) and ((conductive transmissi\$2) adj2 surface))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/01/03 13:20
11	258	250/283.ccls.	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/01/03 13:24
13	10	((conductive transmissi\$2) adj2 surface) and 250/283.ccls.	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/01/03 13:20

12	41	(electrostatic adj3 (field potential)) and 250/283.ccls.	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/01/03 13:20
14	154	250/294.ccls.	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/01/03 13:24
15	896	250/398.ccls.	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/01/03 13:24
16	104	250/400.ccls.	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/01/03 13:24
17	1134	250/294.ccls. 250/398.ccls. 250/400.ccls.	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/01/03 13:24
18	303	(250/294.ccls. 250/398.ccls. 250/400.ccls.) and ((ion dispersive) near3 source)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/01/03 13:25
19	5	((250/294.ccls. 250/398.ccls. 250/400.ccls.) and ((ion dispersive) near3 source)) and (((conductive transmissi\$2) adj2 surface) (((conductive transmissi\$2) adj2 surface) with (hole aperture)))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/01/03 13:25
20	75	((250/294.ccls. 250/398.ccls. 250/400.ccls.) and ((ion dispersive) near3 source)) and (electrostatic adj3 (field potential))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/01/03 13:25